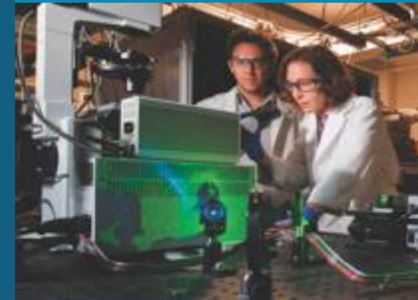




Sandia
National
Laboratories

SAND2019-10740C

Aerosol jet printing of functionally graded materials



Ethan B. Secor, Rebecca R. Tafoya, Bryan J. Kaehr,
Adam W. Cook

Advanced Materials Laboratory, Sandia National
Laboratories



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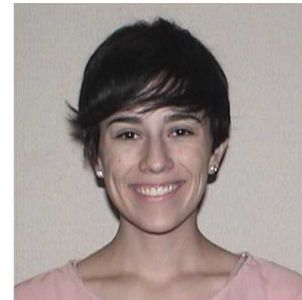


Advanced Materials Laboratory



Materials chemistry, ink formulation, and
advanced manufacturing
Access to UNM to enhance collaboration
and promote student engagement

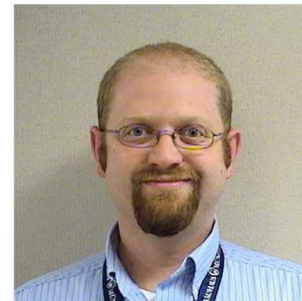
Funding generously provided by the Sandia
LDRD program through the Truman Fellowship



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Adam W. Cook



P. Randall Schunk

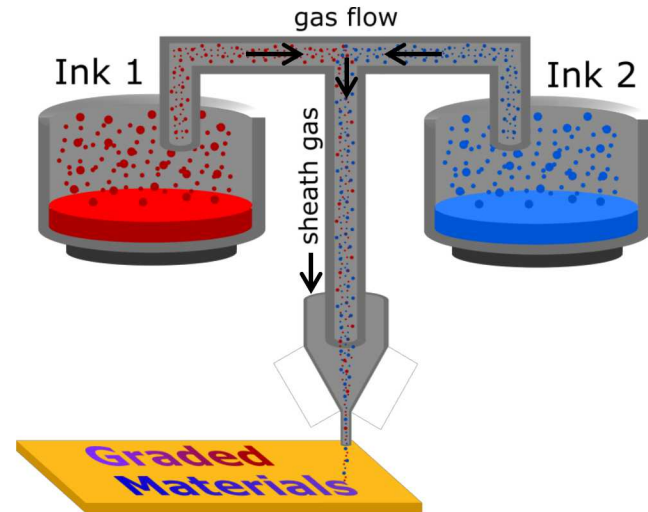
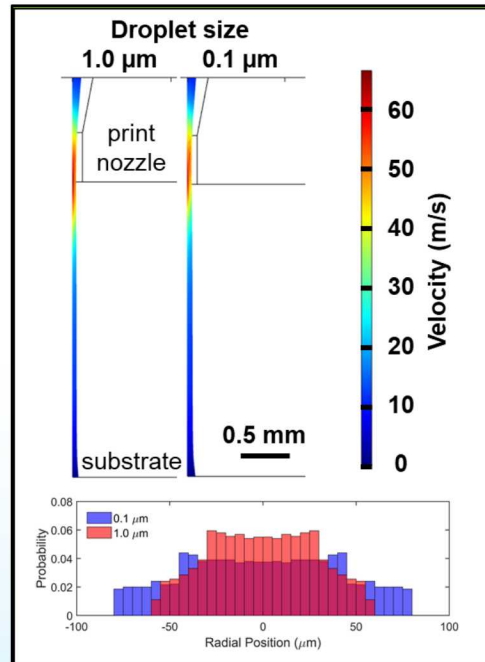
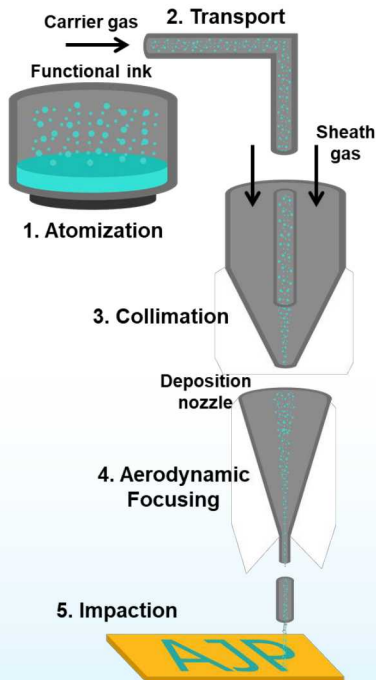


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RESEARCH & DEVELOPMENT



Basics of Aerosol Jet Printing

1. General mechanism
2. Process models
3. Implications for printer design, ink formulation, process optimization



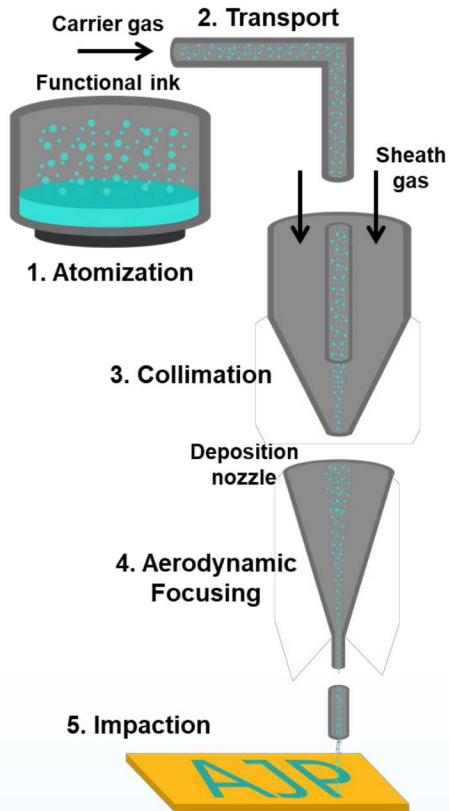
Graded Multimaterial Printing

1. Concept
2. Printhead design
3. Proof-of-concept demonstration
4. Characterization and calibration
5. Functional gradient demonstrations
6. Future work

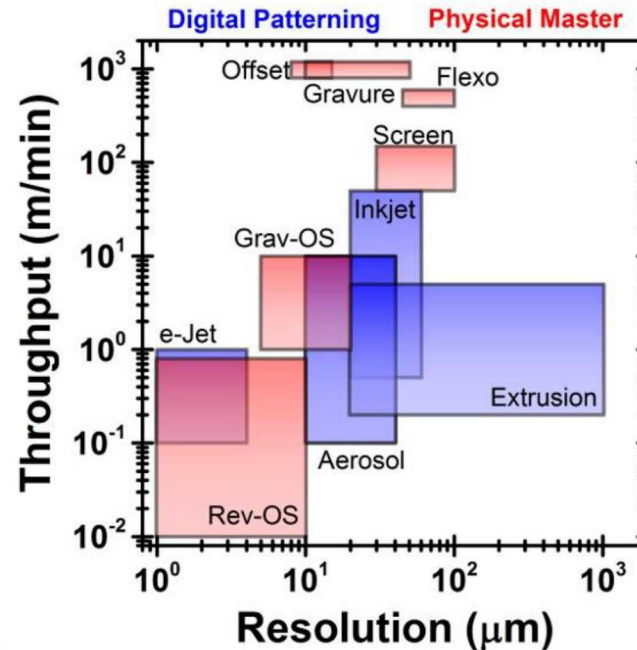
Fundamentals of Aerosol Jet Printing



Aerosol jet printing (AJP) uses focused deposition of micron-scale ink droplets suspended in a carrier gas flow



AJP is a versatile technology for prototyping functional devices

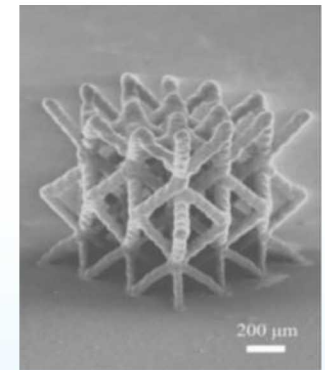
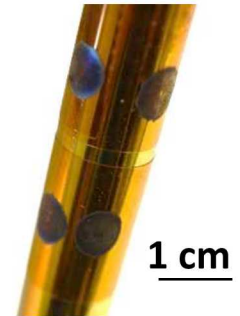
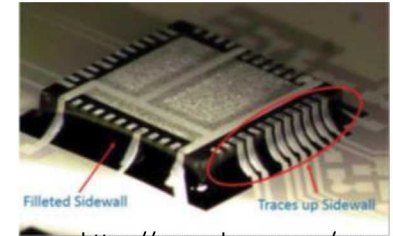


Benefits:

- Digital
- Non-contact
- High-resolution
- Versatile

Limitations:

- Process drift
- Low throughput



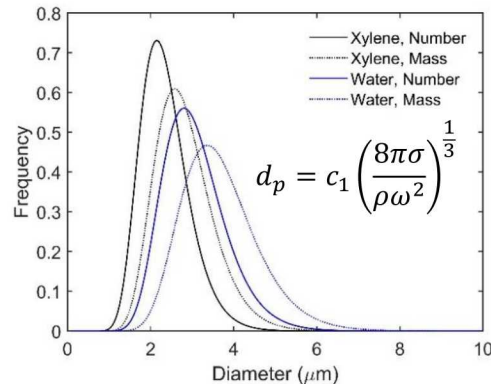
Saleh, H., et al. *Sci. Adv.* (2017) 3, e1601986.

Fundamentals of Aerosol Jet Printing



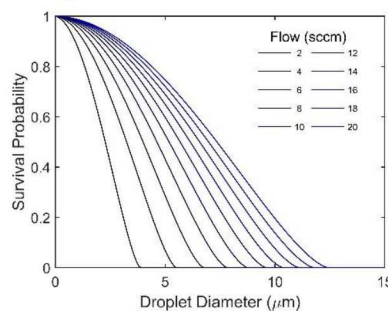
Analytical models of the five physical processes can provide insight when coupled

1. Atomization



2. Transport

$$F = \frac{2}{\pi} (\alpha\beta + \sin^{-1} \beta - 2\alpha^3\beta)$$

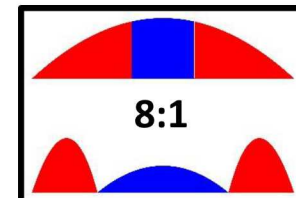


where $\alpha = \left(\frac{3LuTs}{8u_a R} \right)^{\frac{1}{3}}; \quad \beta = \sqrt{1 - \alpha^2};$

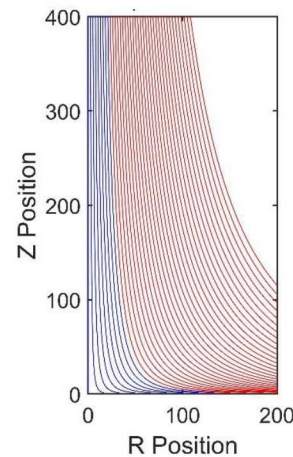
3. Collimation

$$f_a = \int_0^{2\pi} d\theta \int_0^{R_a} r dr \left[2u_a \left(1 - \frac{r^2}{R^2} \right) \right] = \pi u_a R_a^2 \left[2 - \frac{R_a^2}{R^2} \right]$$

$$x_c = \sqrt{1 - \frac{FR}{\sqrt{1 + FR}}}$$



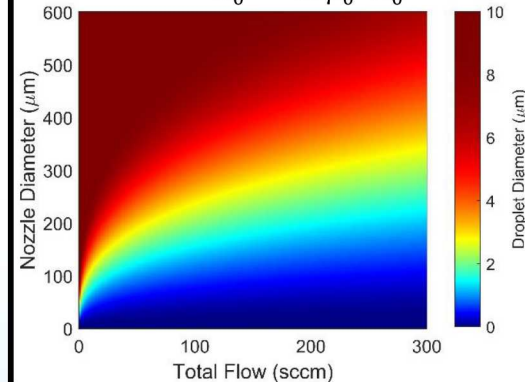
5. Impaction



$$r_0^* \exp[-p] * \left\{ \cosh(pq) + \frac{1}{q} \sinh(pq) \right\}$$

4. Focusing

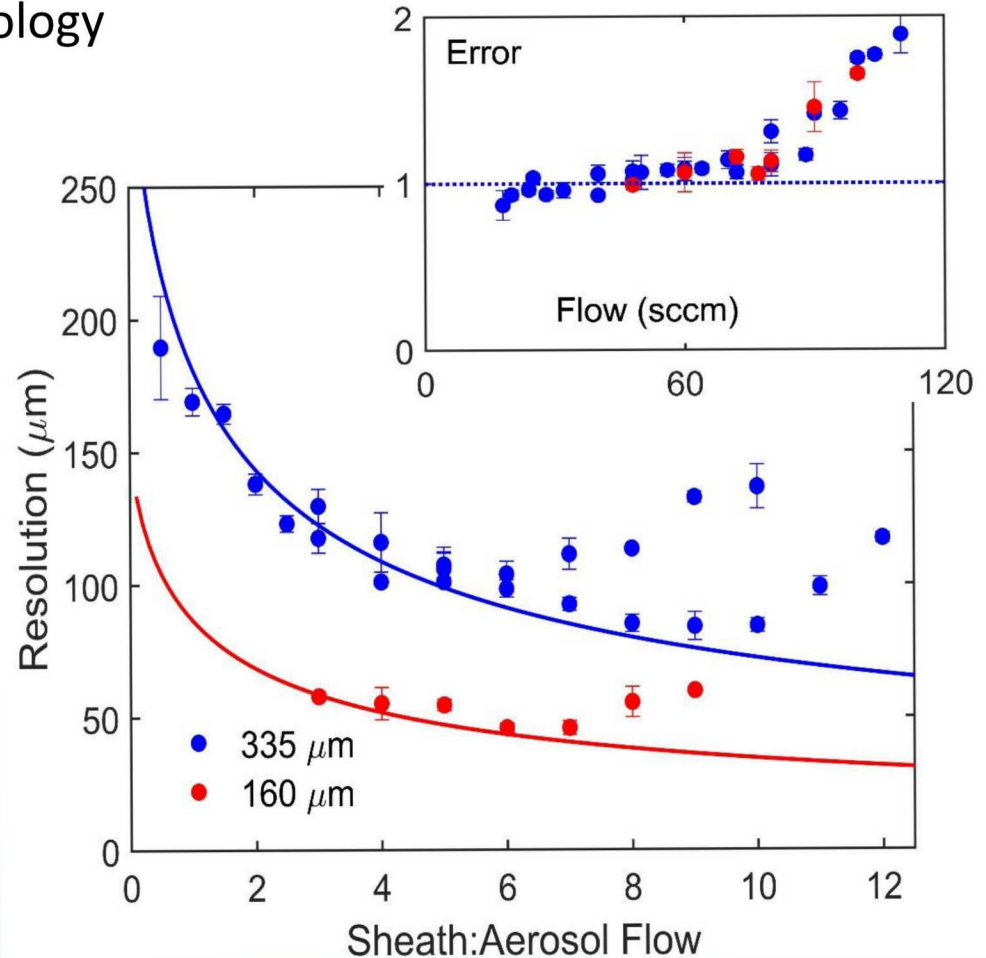
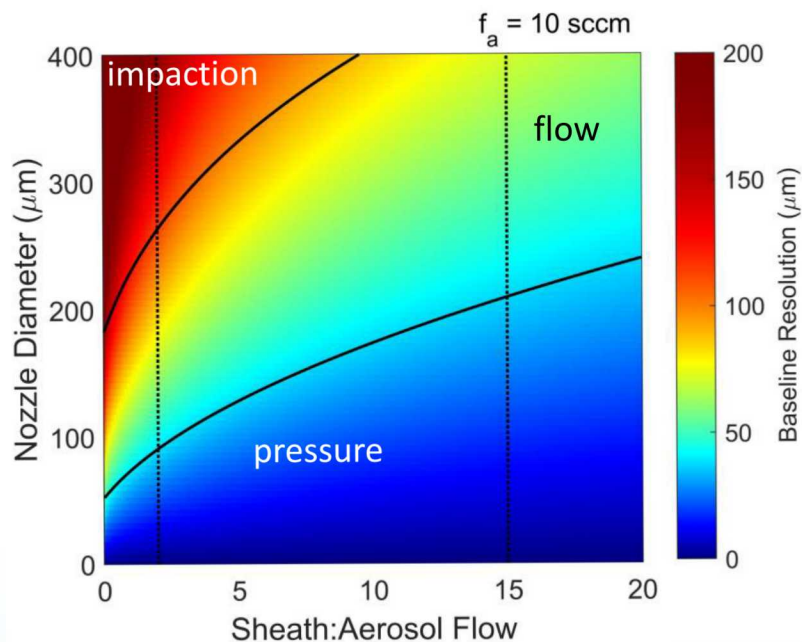
$$St = \tau \frac{U_0}{D_0} = \frac{\rho_p d_p^2 C_c U_0}{18\mu_0 D_0}$$



Fundamentals of Aerosol Jet Printing



Models based on aerosol physics can aid in process design and help improve the technology

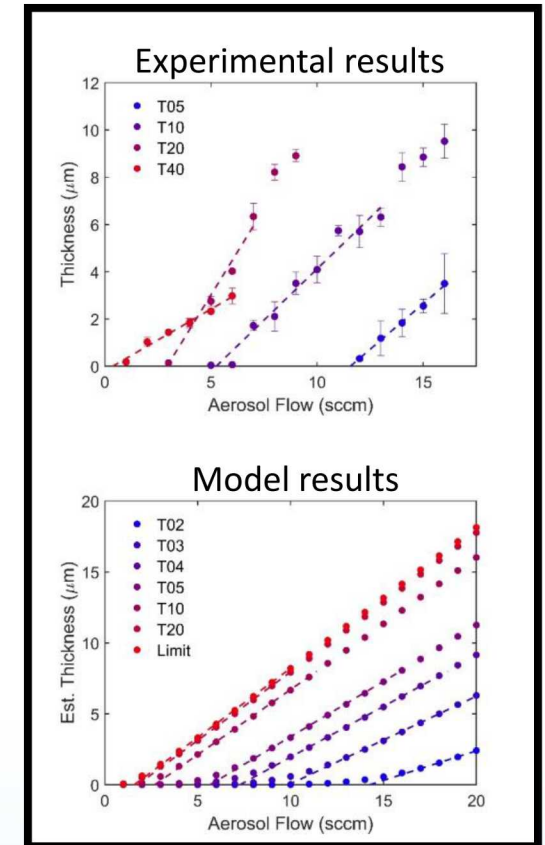
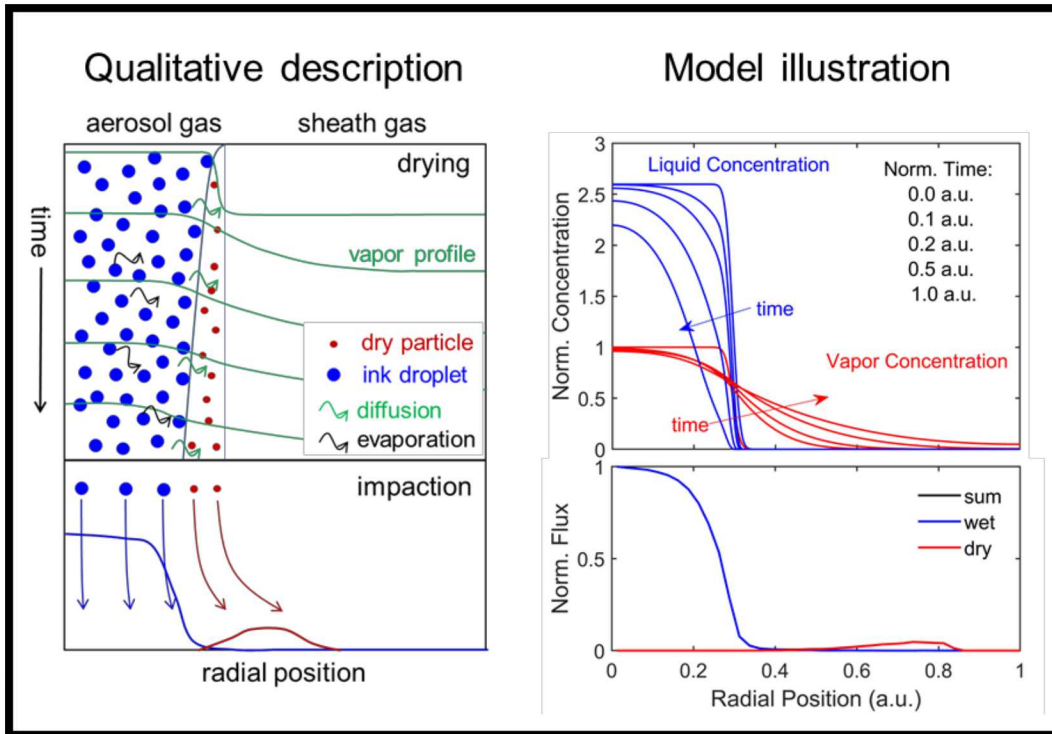


Allows up front description of factors limiting print quality

Fundamentals of Aerosol Jet Printing



Rapid drying within the printhead can have a significant effect on observed performance



$$c_0 = \frac{v_{aero} v_2 V_m}{n_{sat}} * \frac{1}{1 + \chi}$$

$$\tau_{diff} = \frac{R^2}{D} \left[1 - \sqrt{\frac{\chi}{1 + \chi}} \right]$$

$$\tau_{proc} = \frac{L}{u_c} = \frac{\pi L R^2}{2Q} \sqrt{\frac{1 + \chi}{\chi}}$$

$$\tau_{evap} = \frac{a_0^2}{3Dv_a v_2^3}$$

Models streamline ink formulation and provide insight for process optimization

Fundamentals of Aerosol Jet Printing

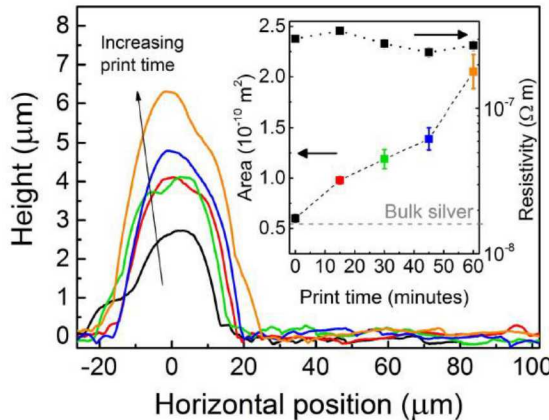


Drift in deposition rate a major challenge for aerosol jet printing in general

Two principle causes to consider

- Ink composition change
Change in cosolvent fractions
Change in solute concentration

- Ink level change
Change in atomization



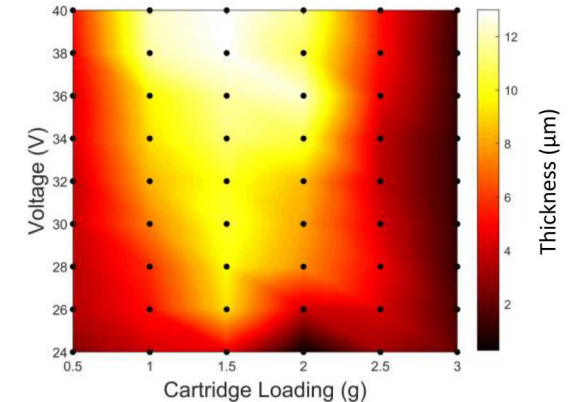
Smith, M., et al. *Flex. Print. Electron.* (2017) 2, 015004.

$$\frac{dv_2}{dt} = \frac{f_a v_a}{V_t} v_1 v_2 \left[\frac{1 - c_{pre,1}}{c_{core,1}} - \frac{1 - c_{pre,2}}{c_{core,2}} \right]$$

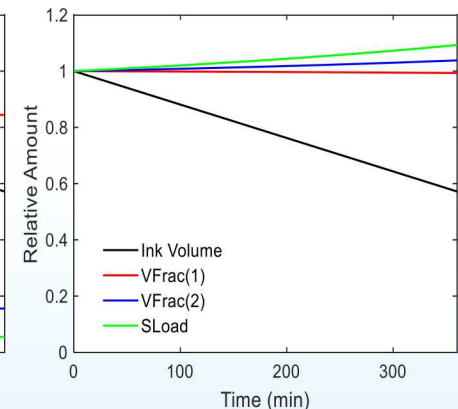
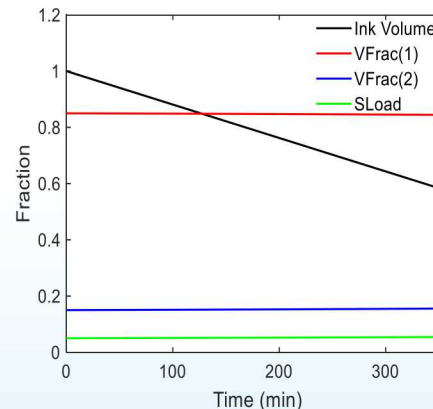
$$\frac{dc_s}{dt} = \frac{f_a v_a c_s}{V_t} \left[v_1 \left(\frac{1 - c_{pre,1}}{c_{core,1}} \right) + v_2 \left(\frac{1 - c_{pre,2}}{c_{core,2}} \right) \right]$$

$$\frac{dV_t}{dt} = -f_a \left[v_a + (v_a v_1) \left(\frac{1 - c_{pre,1}}{c_{core,1}} \right) + (v_a v_2) \left(\frac{1 - c_{pre,2}}{c_{core,2}} \right) \right]$$

where $c_{core,i} = \frac{v_a v_i p_i RT}{m_{w,i} p_{sat,i}}$ is the core saturation,
the relative solvent vapor concentration



estimated time evolution

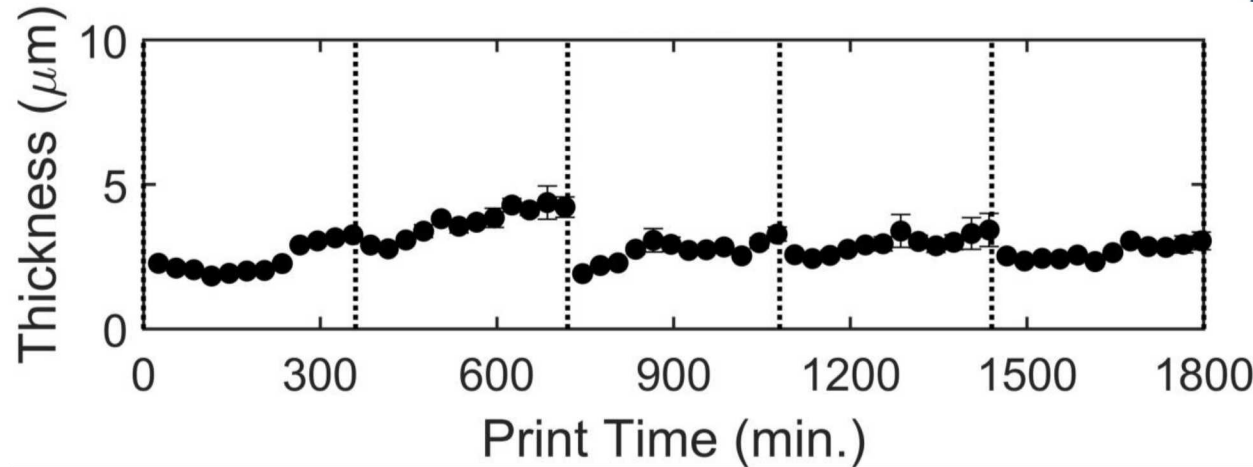
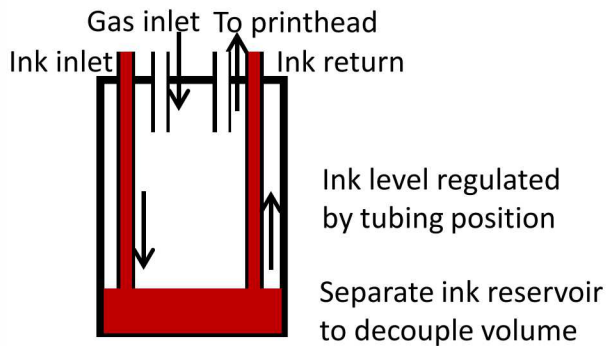


Several causes of drift can be understood and mitigated

Fundamentals of Aerosol Jet Printing



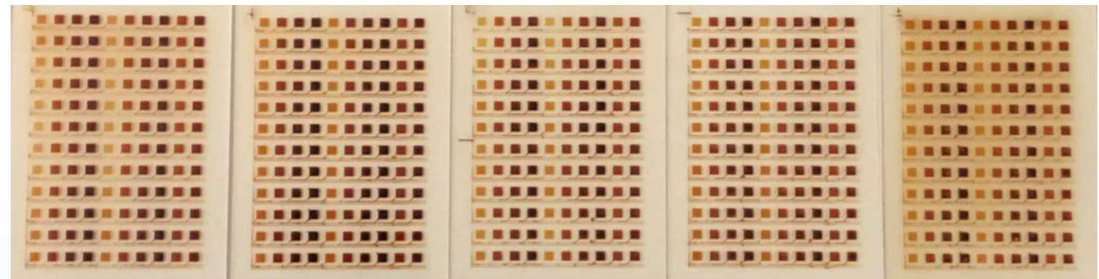
Custom system design provides flexibility to address causes of printing drift



$$\frac{dv_2}{dt} = \frac{f_a v_a}{V_t} v_1 v_2 \left[\frac{1 - c_{pre,1}}{c_{core,1}} - \frac{1 - c_{pre,2}}{c_{core,2}} \right]$$

$$\frac{dc_s}{dt} = \frac{f_a v_a c_s}{V_t} \left[v_1 \left(\frac{1 - c_{pre,1}}{c_{core,1}} \right) + v_2 \left(\frac{1 - c_{pre,2}}{c_{core,2}} \right) \right]$$

$$\frac{dV_t}{dt} = -f_a \left[v_a + (v_a v_1) \left(\frac{1 - c_{pre,1}}{c_{core,1}} \right) + (v_a v_2) \left(\frac{1 - c_{pre,2}}{c_{core,2}} \right) \right]$$



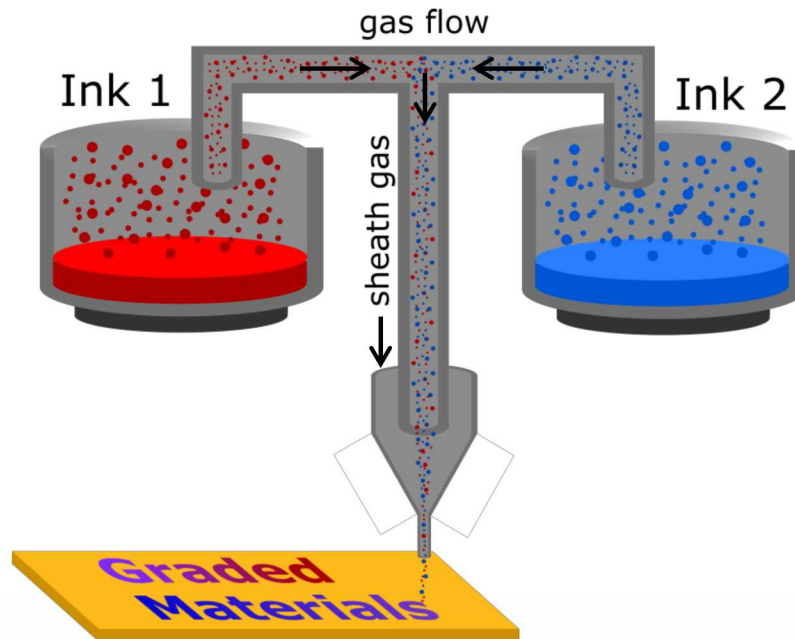
30 hr print test over 5 sessions 1 cm
demonstrates long-duration printing

Recirculating ink cartridge shows promise for extending print duration

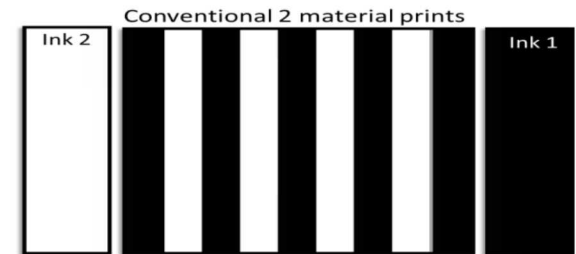
Graded Multimaterial Printing



In-line mixing of aerosols upstream of the printhead for simultaneous codeposition of distinct inks



Binary multimaterial printing



Graded multimaterial printing

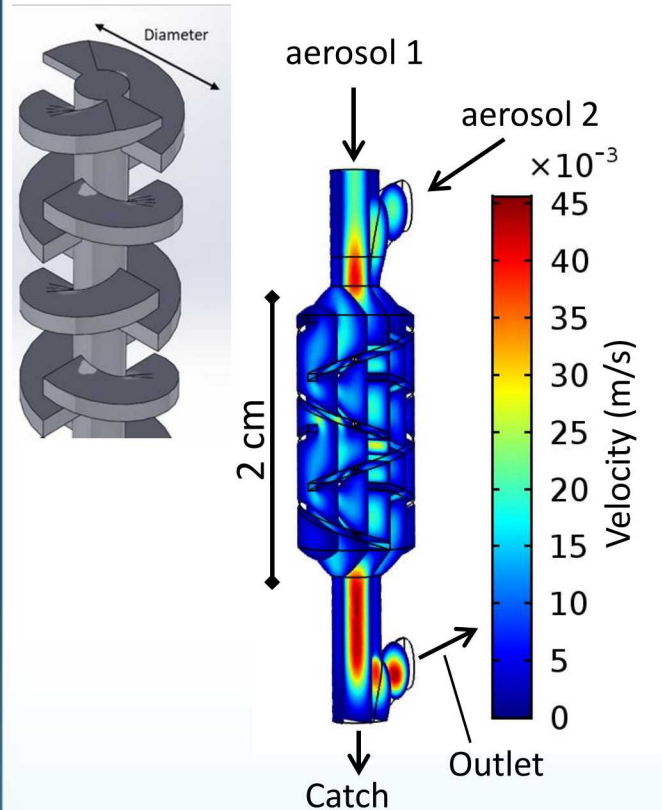


Unique multimaterial printing platform for graded patterning with micron-scale mixing

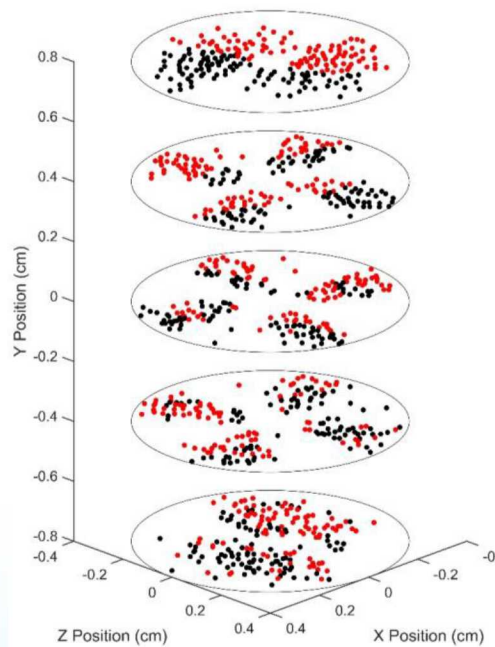
Graded Multimaterial Printing



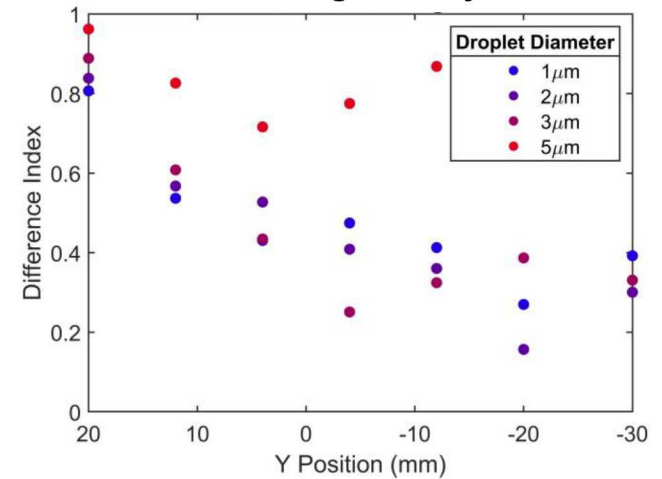
Laminar static mixers modeled for aerosol applications using COMSOL to design custom mixing printhead



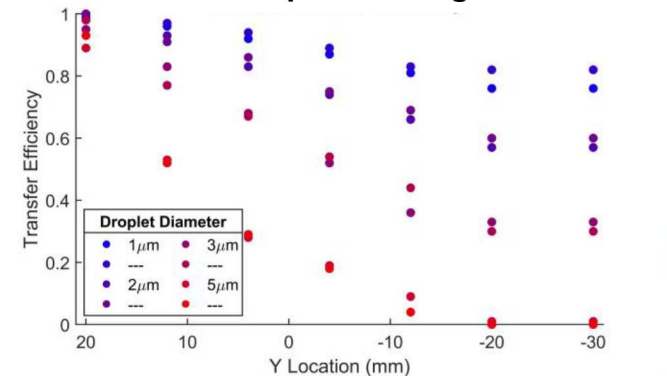
Mixer Cross Sections



Mixing Efficacy



Droplet Settling



A laminar static mixer provides effective mixing of micron-scale aerosol droplets

Graded Multimaterial Printing

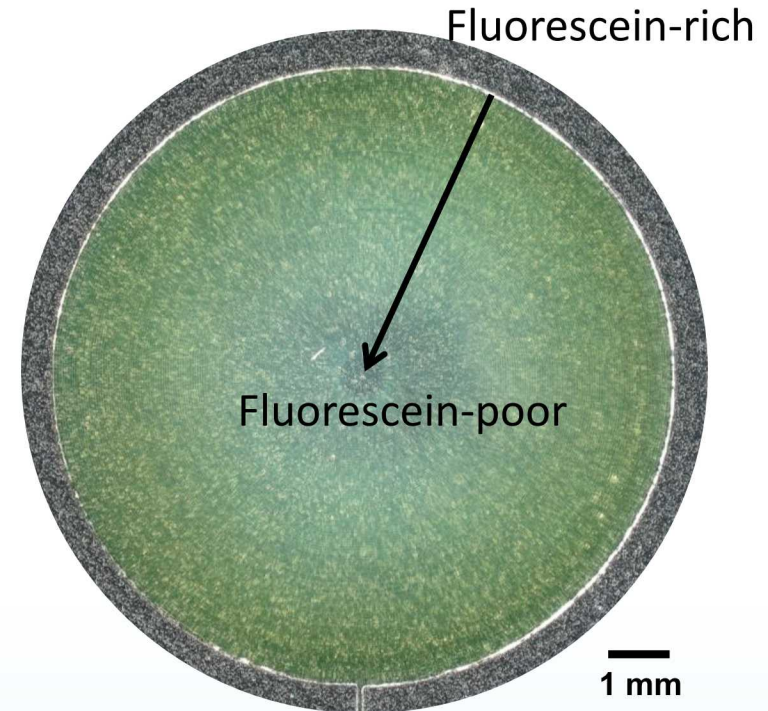


Initial demonstration focused on optical materials for straightforward quantitative characterization

Ink 1: Norland optical adhesive NOA 61

Ink 2: Norland optical adhesive NOA 61 with fluorescein and ZrO_2

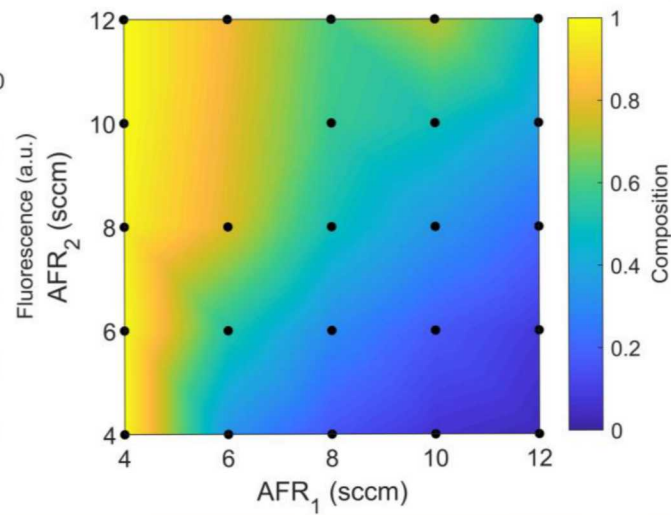
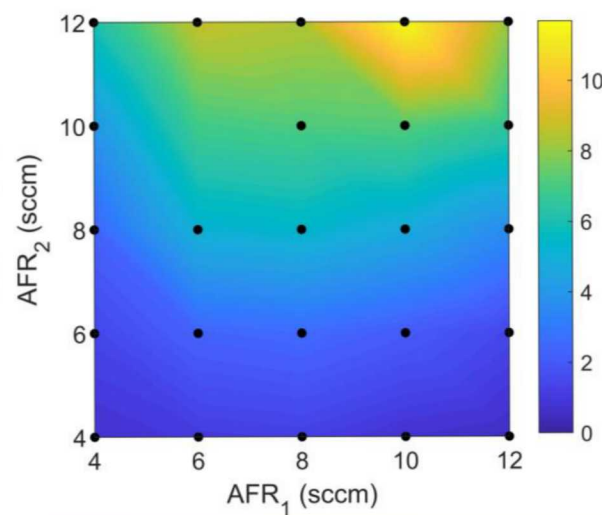
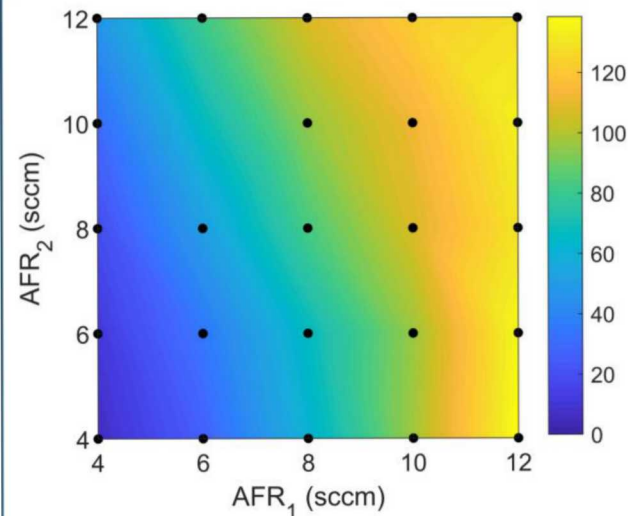
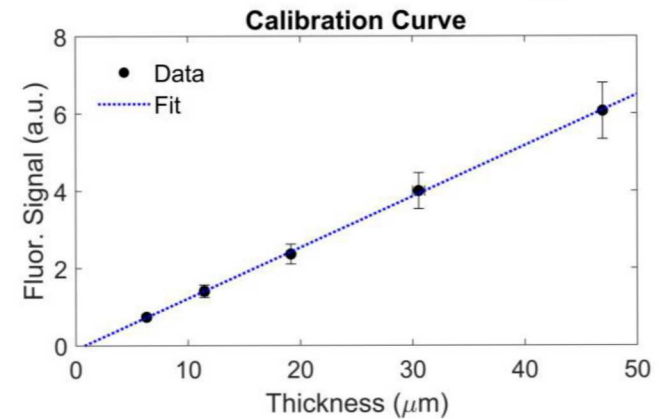
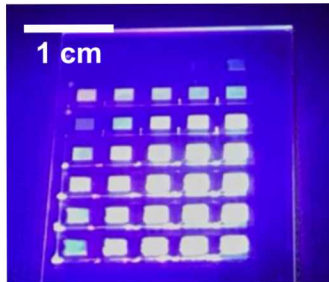
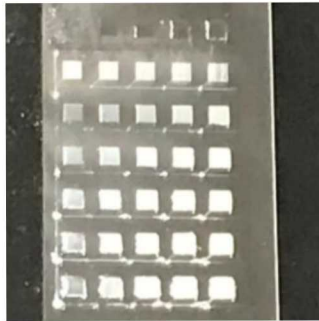
- Fluorescence microscopy measurement to detect fluorescein-containing ink
- Thickness measurement for overall deposition rate
- Calibration required to deconvolute thickness and composition



A fluorescent tracer in an optical matrix provides a useful proof-of-concept experiment



Characterization/calibration

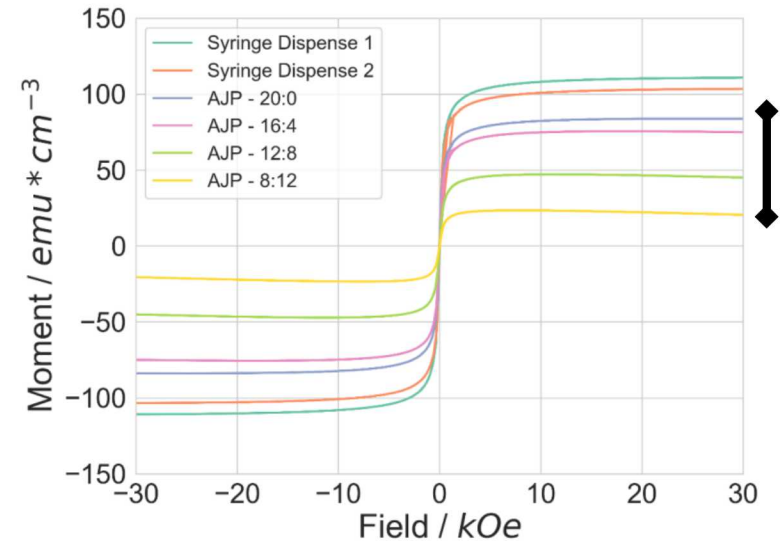
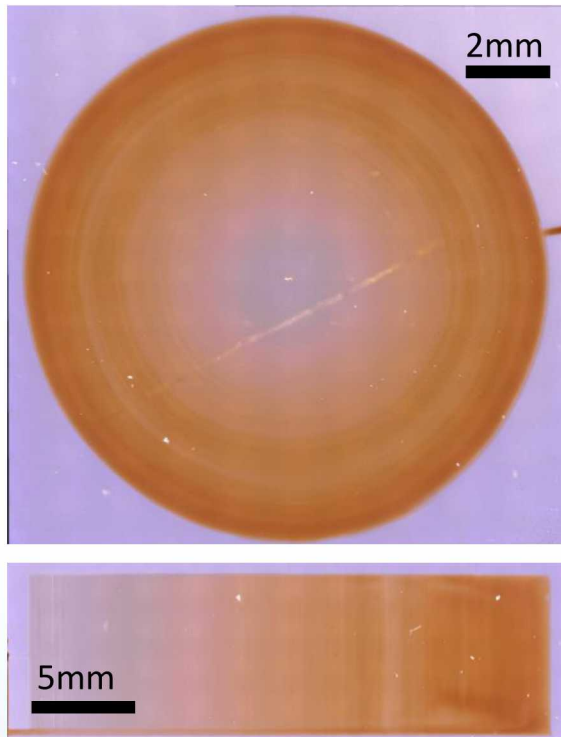


Thickness and fluorescence data allow composition to be estimated for various deposition conditions



Widespread opportunities for functionally graded materials based on broad compatibility of aerosol jet printing

Magnetite composite



Sample (Fe ₃ O ₄ : PMMA)	Fe ₃ O ₄ Loading (mg/cm ²)	St. Dev. (mg/cm ²)
AJP – 20:0	2.39	0.16
AJP – 16:4	1.55	0.08
AJP – 12:8	0.64	0.03
AJP – 8:12	0.35	0.02

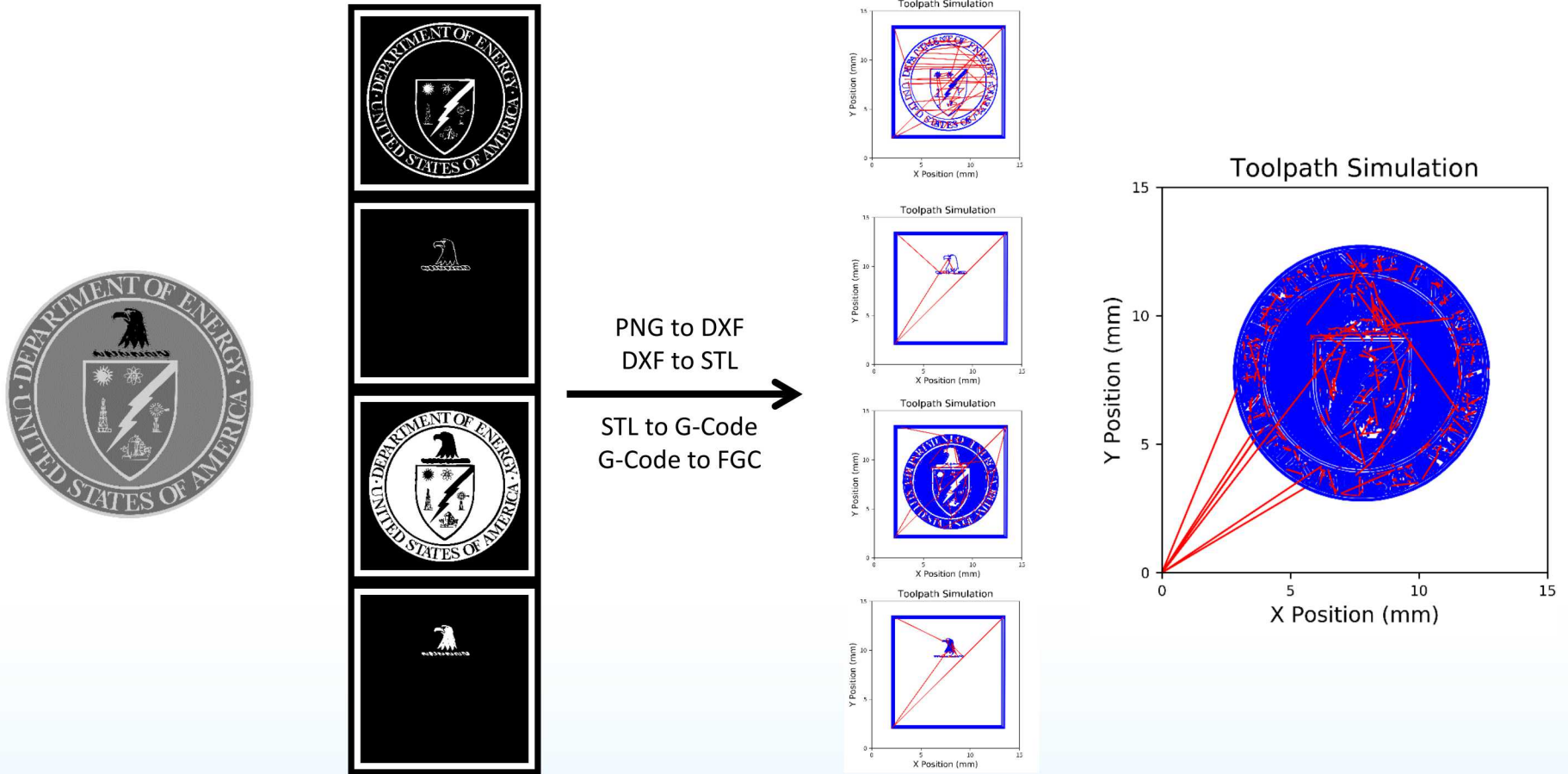
Changing composition of magnetite allows tuning of magnetic properties

Thanks to Dr. Lok-kun Tsui (UNM) for magnetic measurements

Graded Multimaterial Printing



New fabrication capability requires corresponding software for print file generation

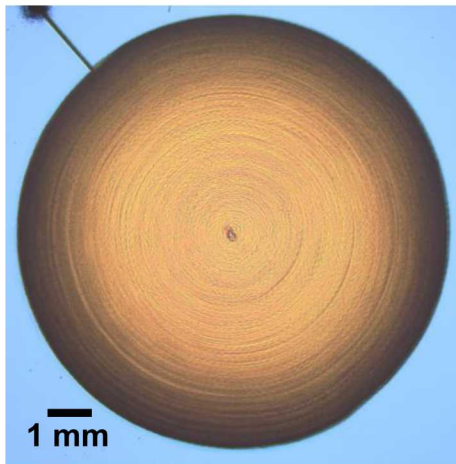


Custom application processes grayscale images for complex toolpath generation



Widespread opportunities in research and applications for advanced fabrication of graded materials

Graphene/magnetite composite



Theoretical understanding of ink design accelerates development of new inks

$$c_0 = \frac{v_{aero} v_2 V_m}{n_{sat}} * \frac{1}{1 + \chi}$$

Broad scope of compatible materials

Epoxies
Acrylates
Polyimide
PMMA
Magnetite
Silver
Graphene
Gold
Metal oxides
Metal hydrides

Mixing only upon deposition relaxes requirements for miscibility of precursors

Graded Multimaterial Printing



Widespread opportunities in research and applications for advanced fabrication of graded materials

EM wave manipulation

- Gradient index of refraction lenses and waveguides for optical applications
- GRIN materials for RF communications and sensing with graded dielectric and magnetic properties

Active electronics

- Graded semiconductors for, ie, diodes and photovoltaics
- Graded thermoelectric materials

Catalysis and Electrochemistry

- Tailor porosity/composition in mixed ion/electron conducting systems
- Engineer electronic band structure for catalysis and sensing

Passive electronics

- Reduce electric and magnetic field gradients at interfaces of magnets and capacitors
- Reduce eddy currents in magnetic materials

Mechanical components

- Thermal expansion at diffuse interfaces
- Graded modulus to reduce stress concentrations at interfaces
- Graded adhesives for bonding dissimilar materials

Multimaterial AJP offers a simple and efficient experimental platform to test a wide range of graded material concepts



Rebecca R. Tafoya



Bryan J. Kaehr

Thanks for your attention!

If interested in more details, check out the poster presentation by Rebecca Tafoya later today



Adam W. Cook

Contact: ebsecor@sandia.gov



P. Randall Schunk

Thanks to Rebecca R. Tafoya, Adam W. Cook, Bryan J. Kaehr, and P. Randall Schunk

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